



Docket No.: 209284US99

ASSISTANT COMMISSIONER FOR PATENTS  
WASHINGTON, D.C. 20231

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ATTORNEYS AT LAW

RE: Application Serial No.: 09/842,734  
Applicants: Zhiyi YU, et al.  
Filing Date: April 26, 2001  
For: STRUCTURE AND METHOD FOR FABRICATING  
SEMICONDUCTOR STRUCTURES AND  
DEVICES USING BINARY METAL OXIDE  
LAYERS  
Group Art Unit: 2811  
Examiner: HU, S.

SIR:

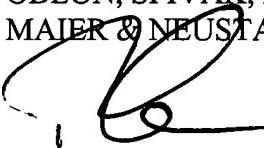
Attached hereto for filing are the following papers:

**RESTRICTION RESPONSE**

Our check in the amount of \$0.00 is attached covering any required fees. In the event any variance exists between the amount enclosed and the Patent Office charges for filing the above-noted documents, including any fees required under 37 C.F.R 1.136 for any necessary Extension of Time to make the filing of the attached documents timely, please charge or credit the difference to our Deposit Account No. 15-0030. Further, if these papers are not considered timely filed, then a petition is hereby made under 37 C.F.R. 1.136 for the necessary extension of time. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND,  
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